

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Masashi Goto et al.

Title: DIELECTRIC FILM, ITS FORMATION METHOD,
SEMICONDUCTOR DEVICE USING THE DIELECTRIC
FILM AND ITS PRODUCTION METHOD

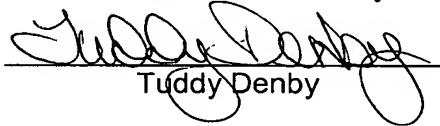
Application No.: TBD

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CERTIFICATE OF MAILING

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Patent Application, Commissioner for Patents, P.O. Box 1450,
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Tuddy Denby

PRELIMINARY AMENDMENT

TO THE COMMISSIONER FOR PATENTS:
P.O. Box 1450
Alexandria, VA 22313-1450

The Applicants request preliminary amendment of the above referenced
patent application as follows.

AMENDMENT

Amendments to the Specification begin on page 2 of this paper.